

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants:	Den Toonder, <i>et al.</i>	Docket No.:	EPC-018
Serial No.:	10/578,027	Conf. No.:	8117
Art Unit:	1793	Examiner:	Janell Combs Morillo
Filed:	November 6, 2008		
For:	Radio-Frequency Microelectromechanical Systems and a Method of Manufacturing Such Systems		

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**ELECTION**

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed on September 13, 2010, Applicants hereby elect Group I: Claims 1-7, for further prosecution in the above patent application. This election is made with traverse.

The restriction requirement is clearly improper. Under PCT Rule 13.1, an international application shall relate to one invention only or to a group of inventions so linked as to form a single general inventive concept ("requirement of unity of invention"). PCT Rule 13.2 states that

Where a group of inventions is claimed in one and the same international application, the requirement of unity of invention referred to in Rule 13.1 shall be fulfilled only when there is a technical relationship among those inventions involving one or more of the same or corresponding special technical features. The expression "special technical features" shall mean those technical features that define a contribution which each of the claimed inventions, considered as a whole, makes over the prior art.

The Examiner states that the first group of claims 1-7 refers to an electronic device comprising a thin film of aluminum and magnesium. Further, the second group of claims 8 and 9 draws to a method of forming a thin film structure with a release layer. It is noted that the fact